

<b>Notice of References Cited</b>	Application/Control No. 10/597,970		Applicant(s)/Patent Under Reexamination VERSCHUREN ET AL.	
	Examiner Tianjie Chen		Art Unit 2627	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,447,900	05-1984	Schatteman et al.	369/200
*	B	US-4,793,480	12-1988	Gelardi et al.	206/308.1
*	C	US-5,526,342	06-1996	Akiyama et al.	720/729
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 63113969 A	05-1988	Japan	MURASUGI et al.	-----
	O					
	P					
	Q					
	R					
	S					
	I					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.